

1 **An ultrahigh-pressure form of SiO₂ glass with dense pyrite-type crystalline homology**

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41

42 **Abstract**

43 **High-pressure synthesis of denser glass has been a long-standing interest in condensed**
44 **matter physics and materials science because of its potentially broad industrial application.**
45 **Nevertheless, understanding its nature under extreme pressures has yet to be clarified due**
46 **to experimental and theoretical challenges. Here we revealed the novel formation of OSi₄**
47 **tetraclusters associated with that of SiO₇ polyhedra in SiO₂ glass under ultrahigh pressures**
48 **to 200 gigapascal confirmed both experimentally and theoretically. Persistent homology**
49 **analyses with molecular dynamics simulations found increased packing fraction of atoms**
50 **whose topological diagram at ultrahigh pressures is similar to pyrite-type crystalline phase,**
51 **although the formation of tetraclusters is prohibited in crystalline phase. This critical**
52 **difference would be caused by the potential structural tolerance in the glass for distortion**
53 **of oxygen clusters. Furthermore, expanded electronic band gap demonstrates that chemical**
54 **bonds survive at ultrahigh pressure. This opens up the synthesis of novel topologically**
55 **disordered dense oxide glasses.**

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I. INTRODUCTION

58 Silica (SiO₂) has been known as one of the most fundamental and abundant oxides in the Earth,
59 which can be usually yielded as quartz, silica sand, or silica stone in high purity condition. Due
60 to this ubiquitous availability and abundant resource around the world, SiO₂ has been extensively
61 utilized as an industrially useful material. SiO₂ glass, with high corrosion resistance, high thermo-
62 stability, and high optical transparency, is a prototype network-forming glass which can be easily
63 synthesized by various methods and it is therefore widely used and a technologically important
64 material. Polyamorphism in SiO₂ glass under pressure is one of the most fascinating and puzzling
65 topics in condensed matter physics and glass science. Several experimental and theoretical studies
66 have been conducted to clarify the details of polyamorphism¹ in SiO₂ glass under high pressure.
67 However, due to the technical hurdles, the experimental studies have been limited to very low
68 pressure conditions, which prevents from a precise understanding of the pressure effect.

69 Previous experimental studies on SiO₂ glass have shown anomalous behavior under lower
70 pressures up to ~10 GPa, exhibiting elastic softening² and permanent densification³. Those
71 densification-related properties are closely related to a topological transformation of the
72 tetrahedral network⁴ and compaction of a significant amount of interstitial cavities in the SiO₂
73 glass⁵, rather than a change in the coordination number of silicon. At higher-pressure, transitions
74 to much denser state are attributed to changes in short- and intermediate-range ordering associated

75 with the change in oxygen coordination around silicon. Although the details on the coordination
76 state and the pressure conditions under which the coordination changes occur are still a matter of
77 debate⁶, it appears that the sixfold-coordinated structure is predominant at 40-45 GPa^{7,8}
78 subsequent to a gradual change in the Si-O coordination number from four to six, which begins
79 around 10-20 GPa⁸, as inferred by a number of experimental measurements including Raman
80 scattering⁹, infrared absorption¹⁰, X-ray diffraction/absorption^{7,8,11,12}, Brillouin scattering^{13,14}, X-
81 ray Raman scattering¹⁵, and neutron diffraction measurements¹⁶. Sato and Funamori¹⁷ have
82 reported that the coordination number of SiO₂ glass remains six at least up to 100 GPa based on
83 the energy dispersive X-ray diffraction measurements, indicating that SiO₂ glass behaves as the
84 corresponding crystalline phase with sixfold-coordinated structure between 40 and 100 GPa.
85 Ultrahigh-pressure acoustic wave velocity measurements on SiO₂ glass up to 207 GPa by
86 Brillouin scattering spectroscopic experiment¹⁸ have revealed an anomalous increase in the effect
87 of pressure on acoustic velocity at ~140 GPa, which was interpreted as a structural transition from
88 sixfold to higher coordination state of silicon above 140 GPa. A series of computational
89 simulations on SiO₂ glass^{19,20} have been conducted subsequently, and they have shown the
90 possible formation of a Si-O coordination state higher than six under ultrahigh-pressure
91 conditions above 100 GPa, which strongly support the experimental findings¹⁸. These results
92 suggest that the SiO₂ glass becomes far denser under ultrahigh-pressure conditions than
93 previously envisioned^{7,8,17}, which significantly reshapes our understanding on the nature of the
94 densification mechanism of SiO₂ glass¹. However, the change in acoustic wave velocity profile
95 as a function of pressure only indicates a structural anomaly, while it does not provide us with
96 any quantitative structural information. Therefore, it still remains experimentally unresolved
97 whether or not such an anomalous increase in the acoustic velocity at ~140 GPa corresponds to a
98 structural change associated with the coordination number increase. In addition, it has been
99 believed that sixfold coordination state in crystalline SiO₂ retains at least above ~700 GPa.
100 Clarifying this issue is thus also important for understanding the analogy between polymorphism
101 and polyamorphism in silica systems under ultrahigh pressures. Very recently Prescher *et al.*
102 performed high-pressure X-ray diffraction measurements up to 174 GPa and confirmed that
103 average coordination number is greater than six at ultrahigh pressures²¹, but atomic structure
104 beyond the first coordination distance nor electronic structure is still unknown.
105 Here, we report the results of state-of-art topological analysis on the basis of atomic configuration
106 obtained by classical molecular dynamics (MD) simulations and density functional theory (DFT)
107 calculations up to 200 GPa. *In-situ* synchrotron high-pressure X-ray diffraction measurements

108 support the reliability of simulation. Our supporting analytical methods include the concept of
109 persistent homology²², and we have placed a special focus on the nature of atomic structure,
110 topology and electronic structures as a function of pressure. Furthermore, we have put emphasis
111 on general understanding of pressure-induced modification in glass structure at atomistic and
112 electronic level to illustrate a motif for densification in comparison with crystalline phases.

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114 II. EXPERIMENT

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A. X-ray diffraction measurements

116 We performed high-pressure *in-situ* X-ray diffraction measurements on the beamline BL10XU at
117 the Japanese synchrotron facility of SPring-8³⁷. Angle-dispersive high-pressure X-ray diffraction
118 spectra were collected on the compressed SiO₂ glass at room temperature in a symmetric diamond
119 anvil cell (DAC) at nine separate runs from 0 to 200 GPa. In each run, a pre-pressed plate of SiO₂
120 glass powder was loaded into a 50 to 100 μm hole, depending on the target pressure condition,
121 drilled in the rhenium gasket without a pressure-transmitting medium. The sample was
122 compressed with 300 μm flat culet and 150 μm beveled culet diamond anvils at lower five
123 pressures and higher four pressures, respectively. The DAC with a large conical angular aperture
124 used in the present experiments allowed the reliable diffraction patterns to be taken in a large
125 angle up to a maximum 2θ of 42°. Pressure was determined using the Raman T_{2g} mode of the
126 diamond anvil³⁸ or ruby fluorescence pressure scale³⁹. An incident X-ray beam was
127 monochromatized, using a diamond double-crystal monochromator, to a beam energy of 49.6 and
128 49.9 keV. The X-ray beam was collimated to ~ 40 μm in diameter, and X-ray diffraction spectra of
129 the sample were obtained by an image plate (Rigaku-RAXIS IV), which has 3000 \times 3000 (pixel)
130 dimensions with a pixel size of 100 (μm) \times 100 (μm)³⁷. Integration of the full-circle scattered X-ray
131 images was performed to give conventional one-dimensional scattered profiles. To subtract the
132 background signals derived mainly from the Compton scattering of the diamond anvils, the
133 background X-ray diffraction pattern was collected for each experimental run after
134 decompression from an empty rhenium gasket hole in a diamond anvil cell after removal of the
135 compressed sample. The Q scale was calibrated using the diffraction pattern from the crystalline
136 CeO₂. Density value of SiO₂ glass under high pressure, which is a key parameter in interpreting
137 measured X-ray diffraction data, was estimated based on the recent results by an X-ray absorption
138 method⁷. The collected data were corrected and normalized to give Faber-Ziman structure factor
139 using a standard program⁴⁰.

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B. MD simulation

142 Molecular dynamics (MD) calculations were performed with Born-Mayer type of pairwise
143 potentials. The potentials of the term of Coulomb interactions with the effective charges of Si and
144 O atoms and the repulsive term described by the exponential functions are calculated by the
145 formula

$$\Phi_{ij} = \frac{e^2}{4\pi\epsilon_0} \frac{Z_i Z_j}{r_{ij}} + B \exp\left(-\frac{r_{ij}}{\rho}\right)$$

147 where r_{ij} is the interatomic distance between atoms, Z is the effective charge, B is the repulsive
148 parameter, e is elementary charge, ϵ_0 is permittivity of vacuum, and ρ is the softness parameter.
149 Supplementary Table 4 gives the parameters for Z , B and ρ .

150 The present calculations were carried out for a system of 3,000 (1,000 Si + 2,000 O) atoms in the
151 unit cell. The volume of the unit cell was determined from the number densities of the SiO₂ glasses
152 under pressures of 10, 31, 46, 83, 109, 140, 170 and 200 GPa. Periodic boundary conditions were
153 used and the long-range Coulomb interaction was treated with Ewald's summation. A time step
154 of 1 fs was used in the Verlet algorithm. The program code for MD simulation was created by
155 ourselves.

156 In the MD simulation, the structural models at different pressures were obtained from random
157 starting atomic configurations. The temperature of the system was kept first at 4,000 K for 20,000
158 time steps, after which the system was cooled down to 293 K during 200,000 time steps. The
159 structural model was finally annealed at 293 K for 20,000 time steps. Five structural models were
160 prepared by repeating the above procedure for the different initial configurations for each
161 condition.

162 We tested also other classical force fields with the LAMMPS program
163 [<http://lammps.sandia.gov>]. The different parameterizations included the ReaxFF⁴¹, COMB⁴²,
164 CHIK⁴³ and BKS potentials⁴⁴ None of these worked properly in terms of density and atomic
165 structure under high pressure of 109 GPa. This analysis highlights the intrinsic limitations present
166 in the current interatomic potentials.

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C. Topological analysis

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1. Cavity analysis

170 The cavity analysis has been performed as described in the previous literature⁴⁵. The system is
171 divided into a cubic mesh with a grid spacing of 0.10 Å, and the points farther from any atom at

172 a given cutoff (here 2.1 Å, and 2.5 Å) are selected and defined as “cavity domains”. Each domain
173 is characterized by a center point where the distance to all neighboring atoms is maximal. The
174 distance cutoff can be varied case-by-case, and the obtained results (volumes) depend closely on
175 this value.

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2. Persistent homology and persistent diagram

178 Given a set of points in the space, the persistent homology captures its topological multiscale
179 structures, and those identified structures are compactly expressed in the format called persistent
180 diagram. The construction of the persistent diagram follows the process described in Fig. 1a. We
181 first replace each point with a sphere and increase its radius from zero to sufficiently large value.
182 This process corresponds to changing resolution of our input data. Then, we record the pair of
183 radii (b, d) at which a void (interstitial, vacancy, cavity) in a specific location appears (birth) and
184 disappears (death), respectively. The persistent diagram is a histogram on the birth-death plane
185 counting of voids at the coordinate (b, d) . From this construction, the persistent diagram enables
186 not only to count the number of voids but also to characterize those shapes and multiscale
187 properties. To provide readers’ a better understanding of persistence diagrams, we show some
188 examples of birth-death pairs for typical regular structures in Fig. 1(b)-(e). For a regular hexagonal
189 points whose distance between points is a , the void appears at radius $a/2$ and disappears at
190 radius a as shown in Fig. 1(b). For a regular triangular configuration, the void appear at $a/2$
191 and disappears at $\sqrt{1/3}a \approx 0.577a$ as shown in Fig. 1(c), and the 1-dimensional persistence
192 diagram for a regular hexagonal/triangular points is shown in Fig. 1(d). For a 2-dimensional
193 persistence diagram, we can similarly evaluate the cavities for a regular tetrahedron and
194 octahedron. The birth and death radii are $\sqrt{1/3}a \approx 0.577a$ and $\sqrt{3/8}a \approx 0.612a$ for
195 tetrahedron, and $\sqrt{1/3}a \approx 0.577a$ and $\sqrt{1/2}a \approx 0.707a$ for octahedron, and they are shown
196 in Fig. 1(e). Therefore, the 2-dimensional persistence diagram of FCC crystal with a bond length
197 a displays two sharp peaks at $(0.577a, 0.612a)$ and $(0.577a, 0.707a)$ corresponding to two
198 types of voids, interstitial tetrahedral and octahedral sites. For further details, we refer the reader
199 to the article on persistent homology²². In our work, persistent diagrams are being used for
200 investigating rings and polyhedral formations in atomic configurations. We also note that the
201 detected rings and cavities are recorded during the computation of persistent diagrams, and hence
202 we can explicitly identify their geometric shapes for further analysis.

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D. DFT simulations

205 The CP2K program^{46,47} was used to perform the DFT simulations of selected snapshot systems.
206 CP2K employs two representations of the electron density: localized Gaussian and plane wave
207 (GPW) basis sets. For the Gaussian-based (localized) expansion of the Kohn–Sham orbitals, we
208 use a library of contracted molecularly optimized valence double-zeta plus polarization (m-
209 DZVP) basis sets⁴⁸, and the complementary plane wave basis set has a cutoff of 550 Rydberg for
210 electron density. The valence electron–ion interaction is based on the norm-conserving and
211 separable Goedecker-Teter-Hutter (GTH) pseudopotentials⁴⁹. The exchange–correlation energy
212 functional is employs the generalized gradient corrected approximation of Perdew, Burke, and
213 Ernzerhof (PBE)⁵⁰. The DFT simulations were performed using a simulation box with 3,000
214 atoms where the starting geometry was constructed by the MD simulation mentioned above. The
215 electronic density of states (DOS) and those with projections onto different elements (P-DOS)
216 were calculated after atomic structure relaxation in a fixed volume (pressure). For each element,
217 the effective volumes and charges were estimated from the atomic configuration and the electron
218 density distribution based on the Voronoi method.

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III. RESULTSTS and DISCUSSIONS

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A. Structural factors and real-space function

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Fig. 2a shows the X-ray total structure factors $S(Q)$ measured up to 200 GPa, together with the $S(Q)$ derived from the MD simulations. The experimental $S(Q)$ are remarkably well reproduced by the MD simulation, although the height of the first sharp diffraction peak (FSDP) observed at $1.5 \text{ \AA}^{-1} < Q < 2.7 \text{ \AA}^{-1}$ is slightly overestimated in the simulations (especially for 10 GPa). The observed FSDP position (see Table S1) shows a drastic and almost linear increase up to 31 GPa, and the FSDP profile becomes much more subtle beyond this point, which is in excellent agreement with the previous studies at least up to 100 GPa^{7,8,12,17}. The second principal peak (PP) observed around $Q \sim 3 \text{ \AA}^{-1}$, which has previously been considered as a manifestation of the presence of octahedrally (sixfold) coordinated Si¹², becomes prominent above 31 GPa, and the peak position gradually shifts to a higher Q region with increasing pressure up to 170 GPa. As shown in Fig. 2b, this behavior is well understood in terms of partial structure factors, $S_{\alpha\beta}(Q)$, in which the evolution of silicon-silicon principal peak increases with increasing pressure. To understand the short-range structure in detail, the average Si-O bond length as a function of pressure was determined based on the first $T(r)$ peak position as well as the MD simulations in real space (Fig. S1), and the numerical values are shown in Fig. 3 together with the previous results^{8,12,17}. Although there are some differences due to pressure conditions and insufficient real-

238 space resolution in experimental data (especially above 83 GPa), the same trend of the Si-O bond
239 lengths is observed among the experimental and MD simulations results. The results indicate that
240 the average Si-O distance increases monotonically with pressure at least up to 46 GPa and turns
241 to decline to 140 GPa, and eventually becomes constant up to 200 GPa. The overall trend of our
242 results is consistent with those of Sato and Funamori¹⁷ up to ~100 GPa and Prescher *et al.* up to
243 174 GPa²¹. According to the estimated bond lengths of six-fold coordinated crystalline SiO₂
244 phase²³ shown as the shaded area in Fig. 3, we suggest that the sixfold-coordinated silicon in SiO₂
245 glass becomes predominant at pressure approaching to 40 GPa.

246 Intermediate-range ordering in AX₂ glasses is of particular interest, because the typical examples
247 of SiO₂ and GeO₂ are very well known as glass forming materials according to Zachariassen's
248 theory³¹. Therefore, it is indispensable to investigate the relationship between the intermediate-
249 range / chemical ordering and the behavior of the FSDP / the second PP in the structure factor.
250 Although the MD simulations overestimate the FSDP heights, those observed for $S_{\text{SiSi}}(Q)$ and
251 $S_{\text{Oo}}(Q)$ appear to disappear at 31 GPa (Fig. 2b). Another remarkable feature is the very sharp PP
252 observed at $Q \sim 2.75 \text{ \AA}^{-1}$ in $S_{\text{SiSi}}(Q)$, which is also observed in X-ray diffraction data (see Fig. 2a).
253 The PP is usually observed at $Q \sim 3 \text{ \AA}^{-1}$ in neutron diffraction data at ambient to low pressures,
254 because it reflects the packing of oxygen atoms^{29,32}. However, our analyzed data suggest that the
255 very intense PP in the X-ray diffraction data is a signature of increased packing fraction of silicon
256 associated with the formation of tricluster and tetracluster configurations while the PP in $S_{\text{Oo}}(Q)$
257 do not change significantly (Fig. 2b). These observations show a clear tendency for the pressure-
258 induced deformation of intermediate-range topological ordering associated with chemical
259 ordering manifested by the evolution of PP. Such a significant diminution of FSDPs with pressure
260 is likely associated with the possible disturbance of the evolution of intermediate-range ordering
261 caused by the pressure-induced diversification of coordination states and polyhedral linkages
262 including an edge-shared connection observed in liquid ZrO₂³³.

263 **B. Si-O coordination numbers**

264 The distributions of Si-O coordination numbers were derived from the MD models and are shown
265 in Fig. 2c where the gradual changes from fourfold to higher coordination can be clearly observed.
266 The fourfold-coordinated structure retains up to 10 GPa almost as a single coordination species.
267 The fivefold-coordinated structure becomes predominant at 31 GPa. The dominant coordination
268 state subsequently shifts to sixfold at the pressure regime between 46 and 109 GPa. Here, a
269 significant rise in the proportion of sevenfold coordination is visible, whereas the fraction of
270 fivefold-coordinated configuration decreases as a compensation. Such a coordination number

271 change with pressure is in a good agreement with the previous results up to 109 GPa^{8,12,17} and up
272 to 174 GPa²¹. However, it is found for the first time that the fraction of the sevenfold coordination
273 state increases up to 40 % at 140 GPa, and becomes eventually greater than that of sixfold above
274 170 GPa reaching a fraction of 53 % at 200 GPa. The remarkable feature shown here is that the
275 SiO₂ glass does not comprise a single coordination state under pressure but exhibits a broader
276 distribution above 31 GPa, such as SiO₆ and SiO₇ polyhedra. Furthermore, the average
277 coordination number is found to change gradually as the coordination distributions evolve. While
278 the observed declining trend in the Si-O bond length at pressures approaching 140 GPa indicates
279 a stable sixfold coordination state which behaves as the crystalline form of silica, the trend above
280 170 GPa showing the constant value can be interpreted as the onset of the average coordination
281 number higher than 6. The corresponding snapshot of the local environment around oxygen atoms
282 at 200 GPa constructed based on the MD simulation (Fig. 4a) highlights the formation of tricluster
283 (OSi₃) and/or tetracluster (OSi₄) configurations that have never been reported previously.
284 Furthermore, Voronoi polyhedral analysis²⁴ also implies the formation of the SiO₆ and SiO₇
285 polyhedra. With a careful inspection of such polyhedral atomic configurations, we find that the
286 Si-O polyhedra exhibit a large variety of distorted features which deviate from the ideal regular
287 polyhedral structures, as shown in Fig. S2.

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289 **C. Bond angle distribution and polyhedral connection**

290 To uncover the atomic structure in SiO₂ glass at high pressures, we have calculated bond angle
291 distributions with pressure, and they are shown as O-Si-O and Si-O-Si configurations in Fig. 4b.
292 The O-Si-O bond angle distribution at 0 GPa shows a fairly sharp maximum close to 109.4° as
293 expected for a regular SiO₄ tetrahedron. The maximum peak position gradually gets smaller down
294 to ~90° up to 83 GPa, and the peak distribution becomes distorted with a broad shoulder at larger
295 angles above ~110°. Although the sixfold-coordinated structure is presumed to be the major
296 component at 83 GPa, the corresponding angle distributions largely deviate from the ideal O-Si-
297 O angle of 90° for a regular octahedron. The broad feature is consistent with the broad Si-O
298 coordination number distribution at high pressure (Fig. 2c), suggesting that the changes in bond
299 angle distributions are due to the wide variety of O coordination around Si at high pressures.
300 The features of O-Si-O bond angles at 200 GPa distinctively differ from those observed at lower
301 pressures. The peaks around 75° and 145° are highly analogous to those observed in the random
302 packing structure of hard spheres, indicating that the structure of SiO₂ glass under ultrahigh
303 pressure is very different from that at ambient pressure. Taken into account our results for the

304 short-range structure, the appearance of such peak/shoulders correlates with the formation of
305 sevenfold or higher coordinated structures in a highly-distorted polyhedral geometry which is in
306 line with the results of Voronoi analysis.

307 The Si-O-Si bond angle distribution shows a peak towards 180° up to 10 GPa, which is a signature
308 of tetrahedral network. On the other hand, the position of the peak shift to small angle region from
309 31 GPa and shows two peaks around 103° (OSi_4 tetracluster) and 124° (OSi_3 tricluster) at 140
310 GPa. The latter peak is not obvious at 200 GPa, suggesting that OSi_4 tetracluster becomes more
311 dominant.

312 In order to shed further light on the nature of the atomic arrangement, the total volume of cavities
313 (“voids”) and polyhedral connections for SiO_n polyhedra were calculated, and are summarized in
314 Table S2. The fraction of cavity volumes exhibits drastic decrease with pressure and there are
315 essentially no cavities above 31 GPa, while the SiO_2 glass initially has a cavity volume of 36.8%
316 at ambient pressure. Previously, it has been considered that the presence of interstitial cavities in
317 the SiO_2 glasses/melts indicates a potential ability to store noble gases, such as helium and argon,
318 within the disordered structures²⁵. The rapid decrease in the cavity volume with pressure
319 approaching 30 GPa offers a feasible explanation for the observation in the previous high-pressure
320 experiments where the solubility of noble gases in SiO_2 melts/glasses drastically decreased at
321 pressures around 10-20 GPa²⁵.

322 Table S2 and Figure S3 also show the pressure-induced change in the polyhedral connections for
323 SiO_n . The connections initially display 100% of corner-shared configurations at ambient pressure,
324 and they show a gradual transition from corner-shared to edge-shared structures together with a
325 minor fraction of face-shared structures.

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D. Topological nature

328 To elucidate the structural information that cannot be sufficiently analyzed by the conventional
329 methods from atomic configurations, we applied a topological/mathematical method using
330 persistent homology for characterizing the geometrical features in amorphous materials²². This
331 method is primarily based on the persistent diagram (PD) which can visualize the persistent
332 homology 2-dimensionally, and thus various topological features such as ring structures and
333 polyhedral connections/distortions can be monitored.

334 Figs. 5a-g show Si-centric PDs $D(\text{Si})_l$ which describe the geometrical features of silicon atoms
335 for the topological dimensionality of 1. We compare 0, 31, 83, and 200 GPa data together with
336 stishovite ($d=4.28 \text{ g/cm}^3$)²⁶, $\alpha\text{-PbO}_2$ type ($d=4.30 \text{ g/cm}^3$)²⁷, and pyrite type ($d=6.58 \text{ g/cm}^3$)²⁸. With

337 those PDs, we can extract the geometrical information of the atoms primarily associated with the
338 1-dimensional linkages such as rings. The profiles along with the death line highlighted by colors
339 are shown in Fig. 5h. In the case of crystalline phase, we can observe systematic peak shift to
340 small death value with increasing density. It is found that a vertical and broad profile along with
341 the death line observed at birth = 2.6 \AA^2 at ambient pressure in glass almost disappears at 31 GPa
342 and an intense profile in both vertical and horizontal appears near the diagonal line at birth ~ 3
343 \AA^2 . This behavior is a good descriptor for FSDP and is consistent with the observation of tricluster
344 and tetracluster configurations under high pressures. Furthermore, peak of glass at 200 GPa is
345 very close to pyrite-type data, although density of the glass is much smaller than the crystalline
346 phase. Similar behaviour is observed in O-centric PDs $D(O)_1$ shown in Fig. S4.

347 Figs. S5a-g shows Si-centric PDs $D(\text{Si})_2$ of glasses and three crystalline phases, which describe
348 the geometrical features of the silicon atoms for the topological dimensionality of 2. With those
349 PDs, we can extract the geometrical information of the atoms primarily associated with the 2-
350 dimensional connections such as polyhedral formation with the reduction of cavity volume. The
351 geometrical configurations having all those characteristics observed above 31 GPa no longer
352 represent a network structure but rather dense packed structure²². The profiles along with the
353 diagonal line highlighted by colors are shown in Fig. S5h. The birth value of broad prole along
354 with the diagonal line rapidly decreases and multiplicity is increased with increasing pressure,
355 which is in line with the behavior of $D(\text{Si})_1$ (Fig. 5). In addition, the profile of glass at 200GPa is
356 similar to that of pyrite-type crystalline phase. On the other hand, O-centric PDs $D(O)_2$ (Figs. 6a-
357 g) show that some data initially distributed along the diagonal line at lower pressure get gradually
358 deviated in a direction toward upper left from the diagonal line with pressure and, eventually,
359 appear to form the isolated cluster-like “island” at 200 GPa apart from the original distribution.
360 The profiles along with the death line highlighted by colors are shown in Fig. 6h, which shows
361 similar behavior with silicon atoms. With the analyses of persistent homology, the emergence of
362 such “island-like” deviation is found to correspond to the formation of the octahedrally-
363 coordinated oxygen atoms (that is SiO_6) whereas the distribution along the diagonal indicates the
364 presence of the oxygen tetrahedra (SiO_4). This interpretation is remarkably compatible with our
365 earlier findings. In addition, recent topological analyses for the metallic glass with highly dense-
366 packed structure²¹ also showed the very similar topological nature in PDs to that obtained under
367 higher-pressure condition in this study, again indicating that the densification is achieved by the
368 gradual transition from network structure to dense packed structure in conjunction with a change
369 in the coordination state.

370 As can be seen in Fig. 2b, $S_{\text{SiSi}}(Q)$ is very sensitive to pressures above 31 GPa, while that of the
371 PP in $S_{\text{OO}}(Q)$ is highly insensitive, which is highly correlated with the pressure-induced changes
372 in PDs D_1 and D_2 , respectively. These behaviors are also very far away from those in densification
373 at lower pressure reported by Zeidler et al²⁹. Pressure-induced structural change in our study could
374 therefore be categorized into the pressure-induced “topological disorder” in the intermediate
375 length scale, associated with chemical ordering under ultrahigh pressure³⁴. This implies that only
376 high pressure can produce such an unusual glass structure at room temperature. Furthermore, our
377 finding paves the way for the synthesis of novel families of highly-disordered, dense glasses from
378 various oxides (including cases with low glass-forming ability) by applying ultrahigh pressure.
379 Recently, Zeidler et al²⁹ proposed a groundbreaking concept on the relationship between
380 coordination numbers and oxygen packing fractions (OPF) in oxide glasses, which gives a
381 universal picture of the coordination number evolution under pressure. This concept is highly
382 supported by the recent high-pressure experimental results on GeO₂ glass up to 100 GPa³⁰,
383 strengthening the predictability of this concept towards configurations under extreme pressures.
384 According to the extrapolated calculations with some assumptions for OPF in SiO₂ glass from
385 previous calculations^{8,16,17}, the onset pressure where the Si-O coordination number becomes
386 higher than 6 is expected around 108 GPa³⁰. This is consistent with the present results for OPFs
387 up to 200 GPa shown in Fig. S6, and supports our previous results for sound velocity as well¹⁸.

388

389

E. DFT calculation

390 We have shown above that the SiO₂ glass undergoes a transition from network- to dense packed-
391 structure in conjunction with the coordination number change under high-pressure. It is expected
392 that most substances with a dense packed ultimately become metallic under extreme pressures,
393 and the question arises whether the SiO₂ glass expresses metallic features under ultrahigh-
394 pressure conditions approaching 200 GPa. To address this issue and to reveal the effects of the
395 changes in Si-O coordination number on electronic states, we computed the electronic structures
396 of the SiO₂ glass by DFT calculations based on the structural models discussed above (samples
397 of 3,000 atoms, fixed volume). The DFT results for the effective charges (Q_{eff}) and atomic
398 volumes (V_{at}) of Si and O atoms are listed in Table S3. The effective charges are remarkably
399 insensitive to pressure exhibiting values close to +2 for Si and -1 for O. On the other hand, the
400 atomic volume of Si appears to decrease monotonically with pressure, whereas the same for O
401 shows a drastic reduction of as much as 50 % within the pressure range 0 - 31 GPa. Since the
402 atomic volume is mainly assigned to O within the Voronoi script, this significant reduction of

403 atomic volumes of O with no changes in the electronic structure and effective charges corresponds
404 to the disappearance of cavity volumes between 0-31 GPa (Table S2) as described above. The
405 reduced volume of O together with the disappearing cavities stimulates the formation of SiO_6
406 from SiO_4 , which is also observed to have its onset around 30 GPa. Owing to such rapid changes
407 in V_{at} , the O and Si volumes approach each other at higher pressures supporting, again, the
408 conclusion that SiO_2 glass undergoes structural changes in line with the hard-sphere-like dense
409 packing without any metallic signature.

410 The electronic structure of SiO_2 glass under pressure was analyzed based on the electronic density
411 of states (DOS). Fig. 7 shows the DOS of SiO_2 glass with projections onto different elements, P-
412 DOS. The distribution of the P-DOS bands is found to become broader with increasing pressure,
413 which reflects the wider distribution of the oxygen coordination number around silicon under
414 high pressures. Despite these changes, the band gaps at the Fermi energy become wider with
415 pressure as shown in Fig. 7, implying that the system remains insulating under pressure. The
416 structural diversity has normally been considered to make the band gap narrower³³, which seems
417 contradictory to the fact that our results shows apparent structural varieties with pressure. One
418 possible reason may be the increase in bond angle symmetry for Si-O-Si whereas the symmetry
419 of O-Si-O decreases with pressure, as can be seen in Fig. 4b. If this is the case, the formation of
420 over-coordinated oxygen with relatively symmetric bond angles may secure the insulation
421 property of the SiO_2 glass under high pressure.

422 To manifest the topology in silica glass under ultrahigh-pressures, we extract the atomic
423 configurations which give an intense multiplicity for $D(\text{Si})_1$ and $D(\text{Si})_2$ of pyrite-type crystal and
424 glass at 200 GPa and show in Fig. 8(a) and (b), respectively. Intriguingly, PD analyses can
425 provides us with information about triclusters and tetraclusters from $D(\text{Si})_1$ and $D(\text{Si})_2$,
426 respectively. Pyrite-type crystal is comprised of only SiO_6 octahedra (OSi_3 tricluster). On the other
427 hand, the formation of a SiO_7 polyhedron is observed in glass as well as SiO_6 octahedra, but its
428 topology is very similar to pyrite-type crystal (see Fig. 8a). As can be seen in Fig. 8(b), tricluster
429 in pyrite-type crystal can be extracted from PD analysis (see left panel), while the formation of
430 OSi_4 tetracluster is observed in glass at 200 GPa (right panel). However, it is found that
431 tetracluster is highly distorted (oxygen atom is off center) and topology is very similar to $\text{OSi}_3 +$
432 Si, in pyrite-type crystal. We suggest that the topological similarity between glass at 200 GPa and
433 pyrite-type crystal would be caused by the distortion of oxygen clusters and the variety of Si-O
434 coordination in terms of disorder in glass.

435

436

IV. CONCLUSIONS

437 In this article, we have investigated the topology of SiO₂ glass MD simulations supported by
438 using the high-energy synchrotron X-ray diffraction technique and topological analyses in a
439 pressure range up to 200 GPa. Our results reveal that the SiO₂ glass undergoes a coordination
440 number change from six to seven at pressure approaching 200 GPa. The atomistic modelling
441 demonstrates the formation of unusual densely arranged local structures around O atoms, such as
442 tricluster (OSi₃) or tetracluster (OSi₄) configurations. The topological analyses succeed in visually
443 discriminating the Si-O coordination changes between fourfold and sixfold using PDs, and reveal
444 that the high-pressure form of the SiO₂ glass exhibits highly distorted structural features, which
445 have so far been unable to be seen by the use of incoherent X-rays and of the conventional analysis
446 tools with defining coordination distances (pair correlation function, bond angle distribution, and
447 so on). Furthermore, we observed the topological similarity between glass and crystal with higher
448 density under ultrahigh-pressure for the first time. This also strongly offers a new direction in the
449 future experiment to determine hidden local symmetries in pair correlation by cross-correlation
450 analysis employing coherent X-rays³⁵. The results also demonstrate that the coordination number
451 change of SiO₂ glass no longer follows that of the crystalline SiO₂ phase under ultrahigh pressures
452 since the sixfold-coordinated structure is believed to persist, at least, up to ~700 GPa for the latter
453 case³⁶. The evolution of Si-O coordination number appears to remarkably follow the universal
454 path for OPF with pressure, as proposed by Zeidler et al²⁹. This pronounced difference between
455 the glass and crystalline phase in pressure-induced structural change is most likely caused by the
456 potential structural tolerance in the glass for accepting the distortion to certain extent, which might
457 provide the glasses with some structural varieties including highly dense-packed arrangement that
458 cannot be achieved in crystalline phase at equivalent condition.

459

460

461 References and Notes

462

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577

578 **Acknowledgments**

579

580 **Funding:** The synchrotron radiation experiments were performed under the approval of the
581 Japan Synchrotron Radiation Research Institute (JASRI) (Proposal No. 2009A1064,
582 2010A1048, 2010B1092, 2011A1239, 2011B1159, 2011B1153, 2013B1217). This research was
583 supported by a Grant-in-Aid for Young Scientists (A) (#22684028), Challenging Exploratory
584 Research (#24654170) and Scientific Research (A) (#25247087) from the Ministry of
585 Education, Culture, Sports, Science and Technology, Japan, a Grant for Program Research from
586 Frontier Research Institute for Interdisciplinary Sciences, Tohoku University, and the Start-up
587 funds at ETH Zürich (to M.M.), This work was supported by JST PRESTO Grant Number
588 JPMPR15N4, Japan (to S.K.) and “Materials research by Information Integration” Initiative
589 (MI2I) project of the Support Program for Starting Up Innovation Hub from JST (to S.K. and
590 Y.H.). JST CREST 15656429 (to Y.H.). The DFT calculations were carried out on the Cray
591 XT4/XT5 computers at CSC - the IT Center for Science Ltd., Finland, and Cray XC30 in Japan
592 Advanced Institute of Science and Technology, Japan. J.A., J.K., T.M. and A.S.F. acknowledge
593 financial support from the Academy of Finland through its Centres of Excellence Program
594 (Project 284621).

595

596 **Author contributions:** M.M. and S.K. designed the research conception. M.M. and N.H.
597 conducted *in-situ* high-pressure synchrotron X-ray diffraction experiments. S.K. performed the
598 atomic structural analyses. H.I. constructed structural model using MD simulations. N.K. and
599 J.A. contributed to the electronic structural analyses. A.H., Y.H. and I.O. were involved in the
600 topological analyses. T.M., A.S.F and J.A tested various parameterizations of the interatomic

601 potentials for MD simulation. N.H. and Y.O. contributed to the optimization of *in-situ*
602 synchrotron X-ray diffraction measurements. Y. Onodera. calculated the OPFs. J.K. and J.A.
603 contributed to the cavity analyses. O.S and Y.I. were involved in the data analyses for atomic
604 and electronic structures, respectively.

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606 **Competing interests:** Authors declare no conflict of interest.

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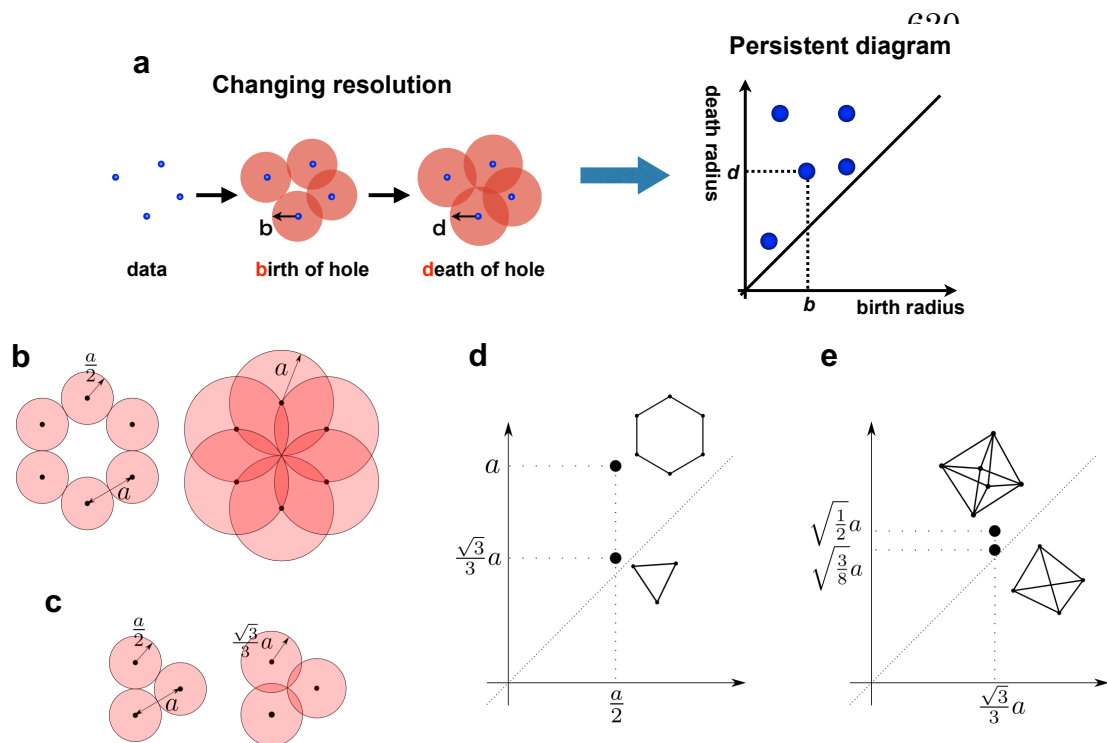
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611 **Figures and Tables**

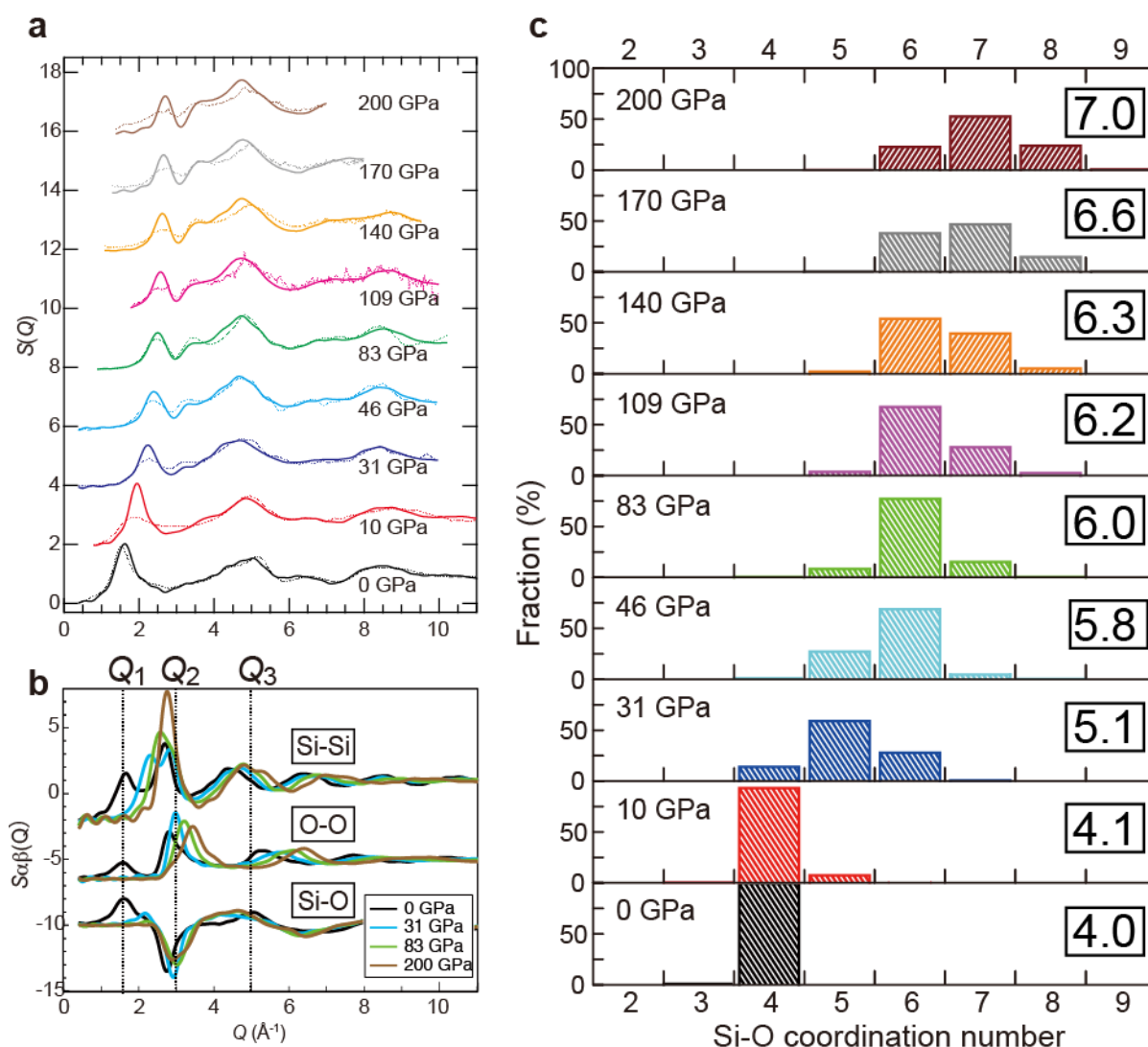
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613 **Fig. 1.** (a) The increasing sequence of spheres for input data (left). The persistent diagram
614 (right) is obtained as a histogram counting the number of voids on the birth-death plane.
615 (b-c) The appearance and disappearance of a void for a regular hexagon/triangle. (d) The
616 pairs of birth and death radii for hexagon and triangle in the 1-dimensional persistence
617 diagram. (e) The pairs of birth and death radii for tetrahedron and octahedron in the 2-
618 dimensional persistence diagram.

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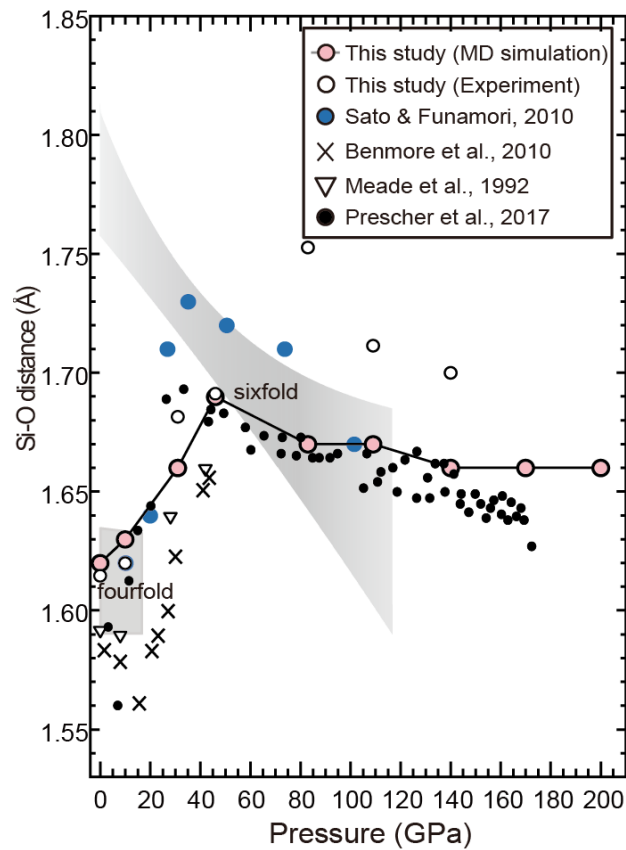
621 **Fig. 2 High-pressure structural data and pressure evolution of Si-O coordination**
622 **number of SiO₂ glass. (a)** X-ray total structure factors $S(Q)$ of SiO₂ glass up to
623 pressures of 200 GPa. Dotted curves, experimental data; solid curves, MD simulations.
624 (b) Faber-Ziman partial structure factors of $S_{\text{SiSi}}(Q)$, $S_{\text{SiO}}(Q)$ and $S_{\text{OO}}(Q)$ up to 200 GPa.
625 The approximate principal peak positions as labeled by Q_1 , Q_2 , and Q_3 observed under
626 ambient condition are indicated by the vertical broken lines. (c) Distribution of the Si-O
627 coordination number in SiO₂ glass as a function of pressure up to 200 GPa. Number in
628 the square denotes the average Si-O coordination number at each pressure.
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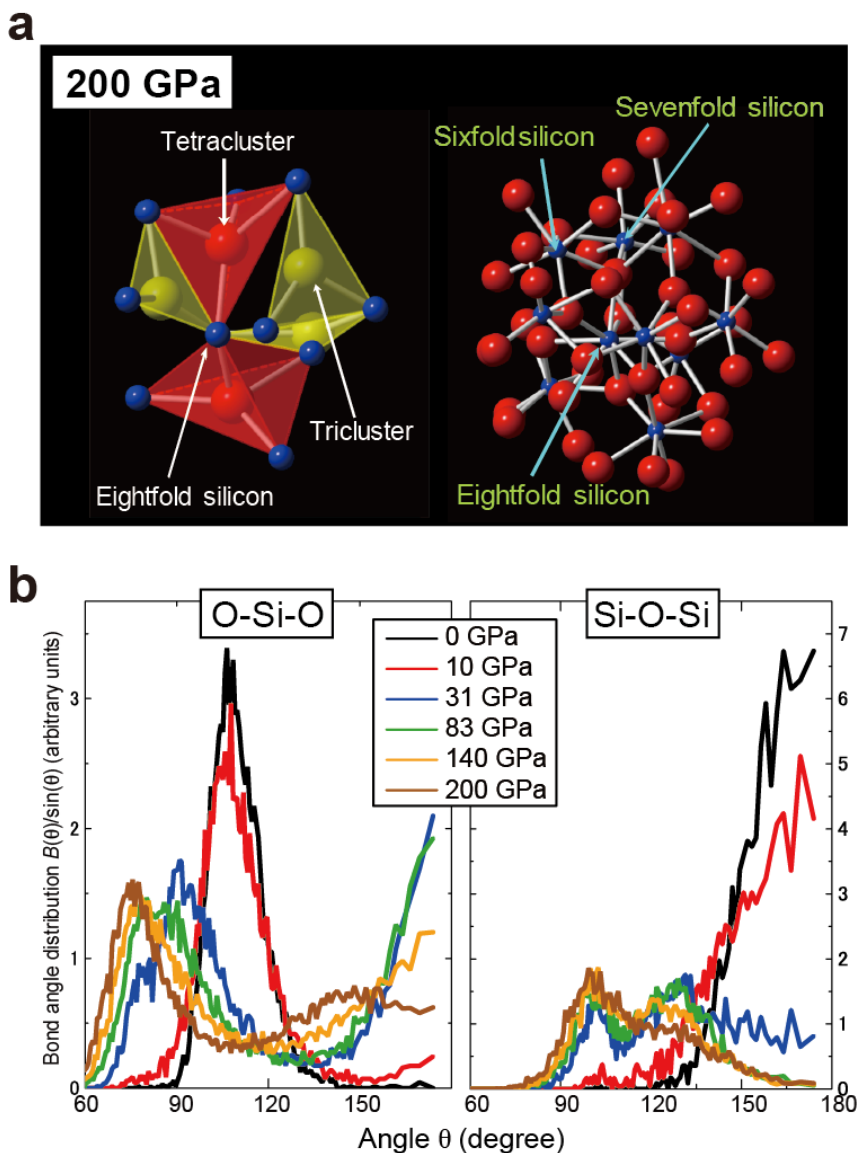
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632 **Fig. 3** Pressure dependence of the Si-O bond length of silica glass up to pressures of
633 140 GPa together with the previous results^{8,12,17}. The shaded areas represent the range of
634 Si-O bond lengths for crystalline silica phases with fourfold- and sixfold-coordinated²³
635 structures.
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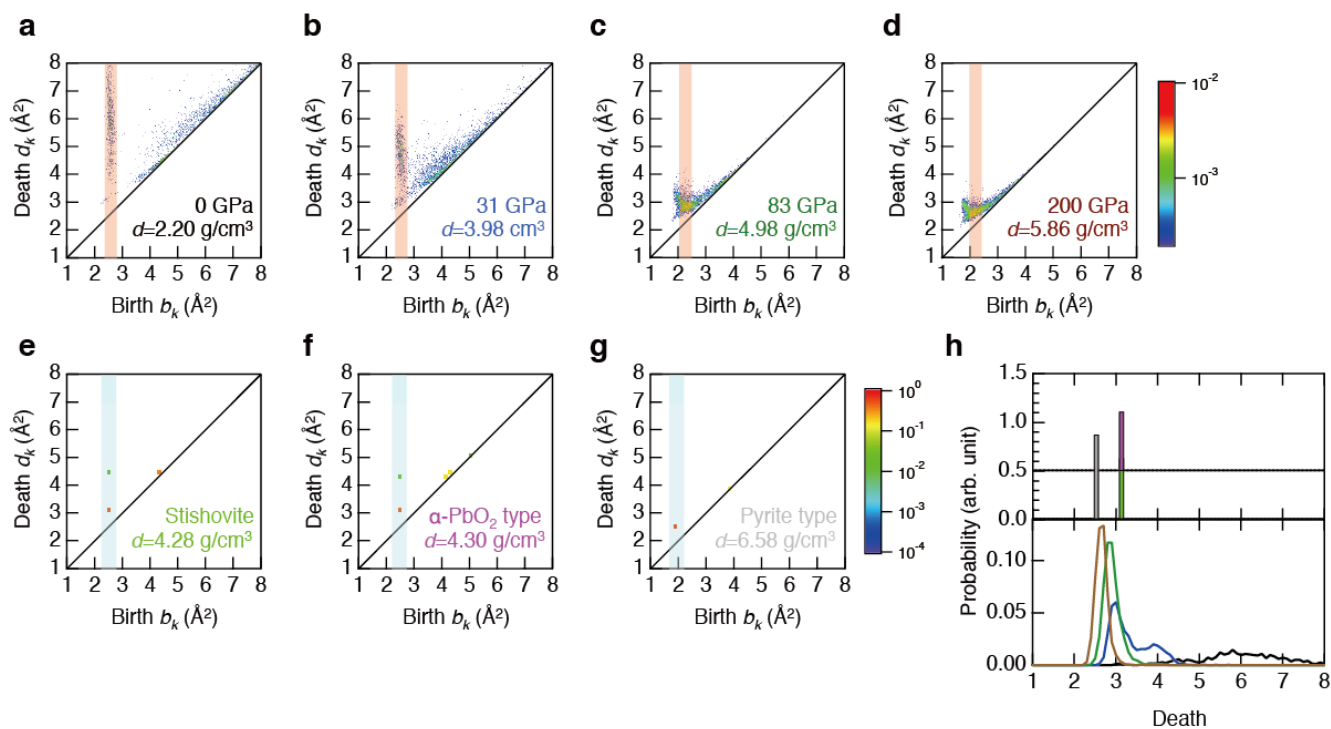
640 **Fig. 4. Atomic structure and bond angle distribution of SiO₂ glass under high-**
 641 **pressure.** (a) Snapshot of the local environment around oxygen atoms at 200 GPa,
 642 highlighting the oxygen tricluster and tetracluster configurations (O coordinated with
 643 three or four silicon). Blue spheres, silicon atoms; yellow spheres, oxygen atoms. (b)
 644 Pressure dependence of the O-Si-O (left), and Si-O-Si (right) bond angle distribution up
 645 to 200 GPa.



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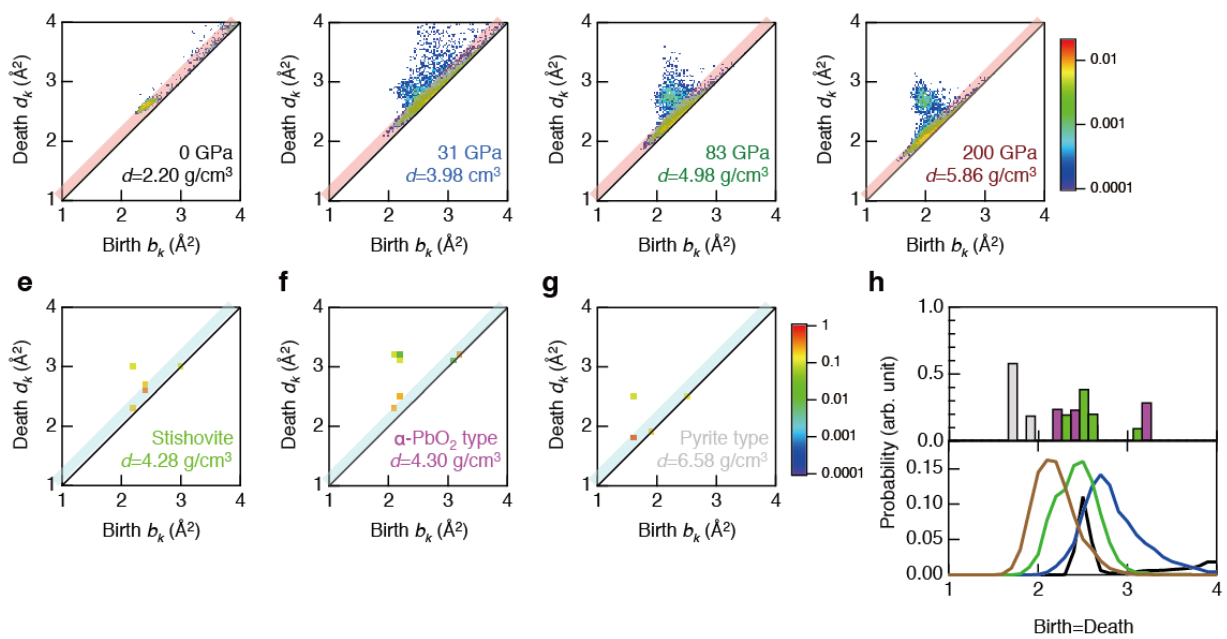
Murakami et al. Fig 2

648 **Fig. 5. Analysis using Si-centric persistent homology for the topological**
 649 **dimensionality of 1. (a-g) Si-centric Persistent diagrams $D(\text{Si})_1$ at 0, 31, 83 and 200**
 650 **GPa (h) The probability profiles along with the death line highlighted by colors.**
 651 **Black line, 0 GPa; blue line, 31 GPa, green line, 83 GPa, and brown line, 200 GPa.**
 652 **Light green, stishovite; pink, α -PbO₂-type SiO₂; gray, pyrite-type SiO₂.**
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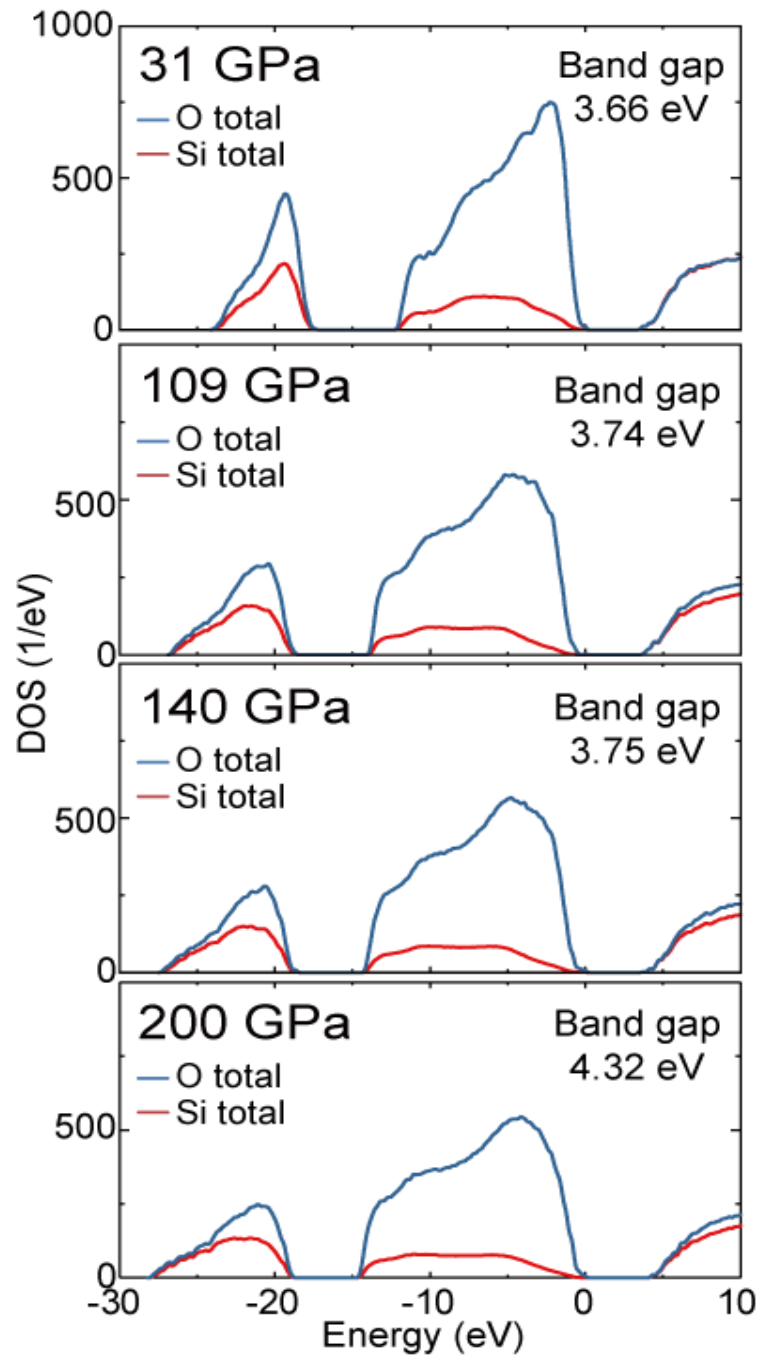
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655 **Fig. 6. Analysis using O-centric persistent homology for the topological**
 656 **dimensionality of 2. (a-g) O-centric persistent diagrams for $D(O)_2$ at 0, 31, 83 and 200**
 657 **GPa (h) The probability profiles along with the diagonal line highlighted by colors.**
 658 **Black line, 0 GPa; blue line, 31 GPa, green line, 83 GPa, and brown line, 200 GPa.**
 659 **Light green, stishovite; pink, α -PbO₂-type SiO₂; gray, pyrite-type SiO₂.**
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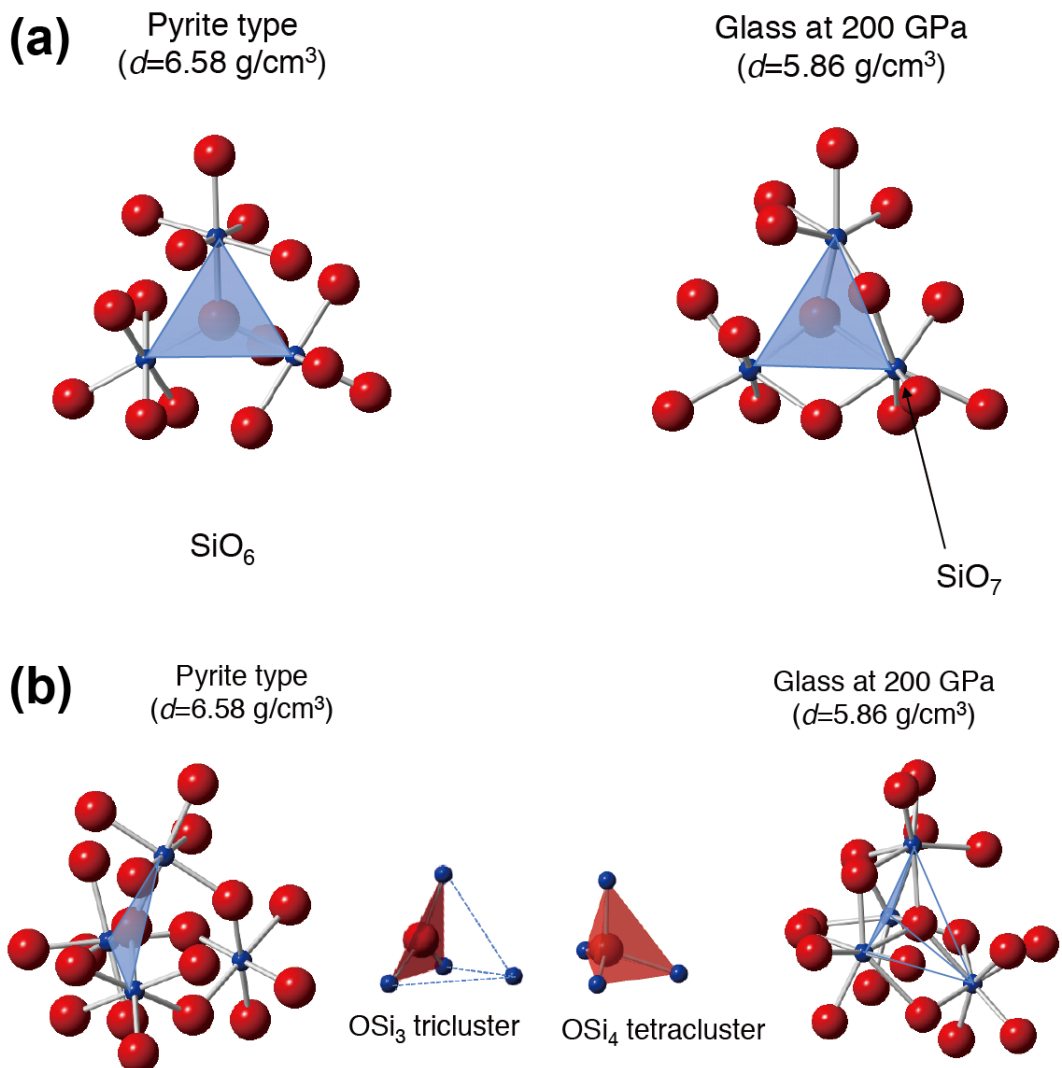
663 **Fig. 7. Electronic structure of silica glass under high pressure.** The electronic
664 density of states (DOS) of the SiO₂ glass with projections onto O and Si up to 200 GPa.
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670 **Fig. 8 | Local structures of pyrite-type crystalline SiO₂ and SiO₂ glass (at 200 GPa)**
 671 **extracted from persistent diagram. (a) SiO_x polyhedra extracted from Si-centric**
 672 **persistent homology for the topological dimensionality of 1. (b) OSi_y clusters extracted**
 673 **from Si-centric persistent homology for the topological dimensionality of 2.**
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